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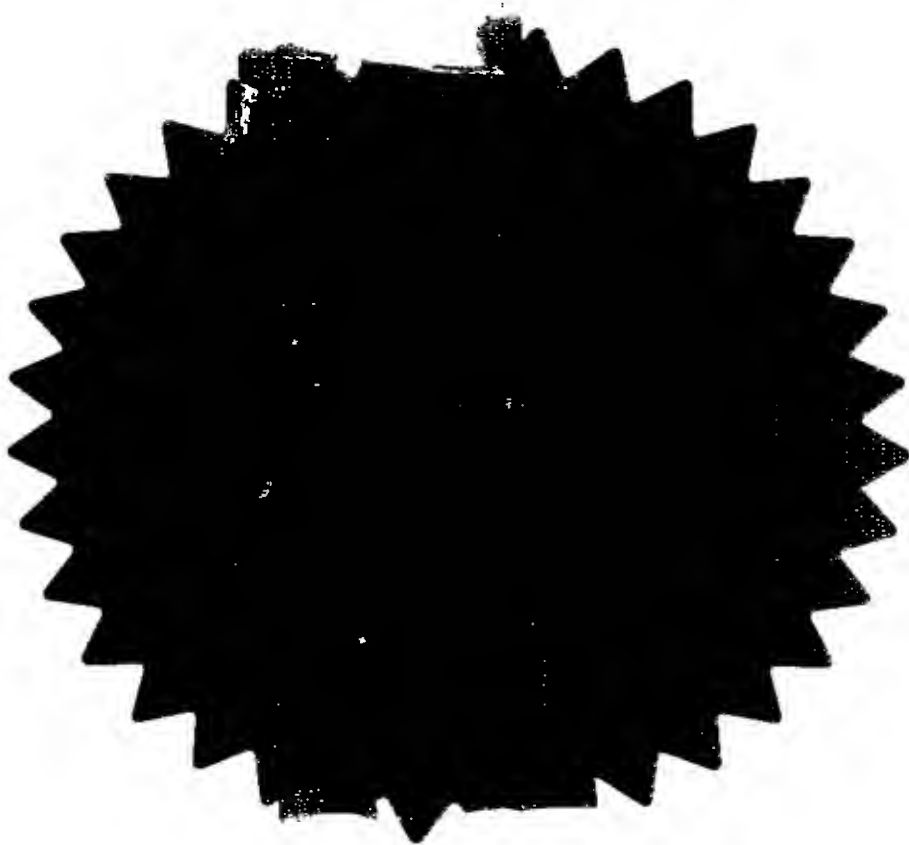
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0403865.9

23FEB04 E875112-1 D00056
POL/7700 0.00 0403865.9 NONE

20 FEB 2004

3. Full name, address and postcode of the or of each applicant (underline all surnames)

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Imperial House
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Patents ADP number (if you know it)

If the applicant is a corporate body, give the country/state of its incorporation

United Kingdom
8302333001

4. Title of the invention

Laser Multiplexing

5. Name of your agent (if you have one)

"Address for service" in the United Kingdom to which all correspondence should be sent (including the postcode)

Kilburn & Strode
20 Red Lion Street
London
WC1R 4PJ

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125001

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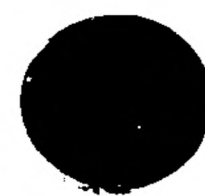
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Date of filing
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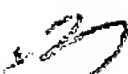
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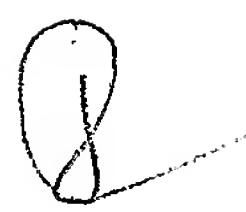
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Description 7

Claim(s) 2

Abstract -

Drawing(s) 3 



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Priority documents

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Statement of inventorship and right to grant of a patent (Patents Form 7/77)

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Gwilym V. Roberts
Tel: 020 7539 4200

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Laser Multiplexing

The invention relates to laser multiplexing for example in high power pulsed lasers.

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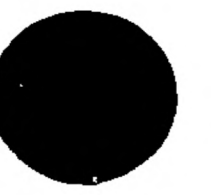
One area in which laser multiplexing is required is Extreme Ultraviolet Lithography (EUVL) which is considered to be one of the most attractive candidates to succeed conventional optical lithography in the coming years. This will permit reduction of structure sizes in semiconductor devices to less than 30nm. To enable this technology, a light source is required that emits in the spectral range around 13.5nm. The Laser Produced Plasma (LPP) EUV source described for example in US2002070353 and WO021978 has great potential to be the future source for EUV lithography, and offers several advantages over discharge-based EUV sources. These advantages can be summarised as: power scalability through tuning of lasers parameters, low debris, pulse-to-pulse stability (optimum dose control), flexibility in dimensions, spatial stability, minimal heat load and large solid angle of collection.

20 The main requirements for the LPP EUV source are the availability of a refreshable, efficient target as well as high peak laser intensity and high average laser power on the target. In order to generate optimum conversion efficiency (CE) from laser light to EUV radiation (particularly wavelengths in the vicinity of 13.5nm), peak intensity (I) on Xe target is required to be in the range 10^{11} - 10^{13} W/cm²:

25

$$I(\text{W/cm}^2) = E_L / (A\tau) \dots \dots \dots (1)$$

where E_L is the laser pulse energy (joules), A is the focal spot area of the laser beam on target (cm²) and τ is the laser pulse duration (seconds).



Although it is trivial in order to obtain higher powers to combine two highly polarised lasers into one co-linear beam using a polarising beam splitter and polarisation rotation optics (waveplates), this technique cannot combine more
5 than two lasers and cannot be applied to unpolarised lasers.

In one approach known as Master Oscillator Power Amplifier (MOPA), a single large, complex laser system is employed in order to satisfy the input power requirements. Scale-up is achieved for instance by adding amplifier
10 modules after the laser oscillator in order to boost output power. However various problems arise with this system. Firstly, limited flexibility is offered in terms of scalability. Secondly, if a fault occurs on one of the amplifier modules, the complete EUV system is shut down.

15 In another known approach shown in Fig. 1, the outputs of several smaller laser modules 100, 102, 104 are combined using a single focussing optic 106 in order to achieve the required peak intensity (Equation 1) on target 108 and therefore the optimum conversion efficiency. The focal spots of all beams 110, 112, 114 are ideally equal in size and perfectly overlapped in space to ensure
20 that the required peak intensity is achieved.

However, problems arise with this system as well. For example, the focal spot size of any given beam can depend on its position on the optic's surface if the lens is not of sufficient quality that spherical aberration can be neglected.
25 Furthermore, if the lens diameter needs to be increased for example to accommodate a larger number of laser beams, it becomes increasingly expensive and difficult to manufacture a lens of sufficient quality.



In a further known approach, multiple laser optics are used. This approach to increasing the pulse energy on target using multiple laser beams has been demonstrated extensively in laser fusion work at the Rutherford laboratory, National Ignition Facility (NIF) and other large-scale laser facilities. The method involves focussing many beams from a variety of angles in order to illuminate the fusion target. Each beam-line employs its own focussing element in order to achieve the desired peak intensity on target.

However, in this configuration the beam lines completely surround the target, severely limiting the collection efficiency of any generated EUV radiation.

The invention is set out in the attached claims.

Embodiments of the invention will now be described by way of example with reference to the drawings, of which:

Fig. 1 shows a prior art laser multiplexer;

Fig. 2 shows a schematic diagram of a spatial laser multiplexer according to the invention;

Fig. 3a shows a schematic diagram of a temporal laser multiplexer according to the invention;

Fig. 3b shows a timing diagram for the multiplexer of Fig. 3a; and

Fig. 3c shows an alternative temporal multiplexer according to the invention.

In a first embodiment of the invention shown in Fig. 2 an LPP EUV system is designated generally 200 and includes an LPP chamber 202 of any appropriate type including a collector (not shown) and a target 204. A plurality of laser sources 206a, 206b, 206c generate laser beams 208a, 208b, 208c. The beams are directed onto an array of respective closely spaced, small lenses 210a, 210b, 210c, forming a so-called 'fly-eye' arrangement. Each lens



accommodates 1-2 laser beams and the whole optical assembly constitutes a compound lens that focusses N laser beams onto any type of target through chamber window 205, particularly for the purpose of generating EUV radiation.

5

An appropriate laser is a pulsed, diode-pumped solid state laser (e.g. Powerlase model Starlase AO4 Q-switched Nd:YAG laser). A standard single element positive lens (plano-convex, or bi-convex, antireflection coated) would be a suitable element for a 'fly-eye' compound lens (e.g. 300 mm focal length, 1" diameter, fused silica, plano-convex lens with anti-reflection coating for 1064 nm light - CVI Laser LLC, part number PLCX-25.4-154.5-UV-1064). The optical performance could be optimised using any appropriate commercial software package (e.g. Code V from Optical Research Associates)

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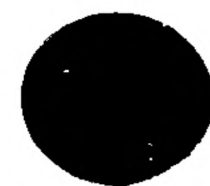
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Combining multiple lasers using the spatial multiplexing method described above offers several advantages over prior art LPP driver arrangements. For example compared to using a single high power laser greater flexibility is offered in terms of scalability. Secondly, if a fault occurs on one of the multiplexed modules, the EUV system can continue to run (albeit at slightly reduced output power).

25

Compared to a spatial multiplexing scheme involving a single focussing optic, the focal spot size of any given beam does not depend on its position on the optic's surface such that lens quality is less determinative. However, if the lens diameter needs to be increased for example to accommodate a larger number of laser beams, in the fly-eye scheme, smaller, readily available and high quality lenses can be employed in order to minimise the effect of aberrations.



Furthermore, in contrast to systems using multiple independent focussing optics, the fly-eye compound lens gives a larger solid angle in which EUV can be collected as the laser radiation is confined to a narrow cone.

5 In a second embodiment shown in Figs. 3a to 3c, the laser power incident on a target is increased using temporal and angular multiplexing to combine several source laser beams into a single, co-propagating output beam. The technique may be made independent of the polarisation states of the source laser beams.

10 A number of source laser beams 300a, 300b, 300c of the type described above are directed at an optical element 302, in this case a rotating mirror or prism which introduces a time-varying angular deviation to the beams. The angle of incidence of each source beam 300a, 300b, 300c upon the deviating element 302 is unique.

15

Each source laser beam consists of a train of discrete pulses separated in time by the reciprocal of the laser repetition frequency. As can be seen in Fig. 3b which illustrated the system for 3 lasers, the timing of the source lasers is arranged such that their output pulse trains are temporally interleaved and
20 therefore the arrival time of each laser pulse at the deviating element is unique. The time-variation of the deviating element is arranged such that an incident pulse from any of the source lasers is made to propagate along a common output path.

25 In the case of the rotating reflective prism 302 shown in Fig. 3a, the prism is of hexagonal cross-section. Because the prism 302 is rotated, and the source laser beams 300a, 300b, 300c are successively pulsed, a single face of the prism presents a different angle of incidence to each source beam pulse. Accordingly the rate of rotation of the prism can be determined such that the variation in



angle of each source beam is effectively compensated such that the beams are all reflected along a common output path 304.

5 It will be appreciated that various alternative arrangements can be provided, for example a reciprocating mirror or the variant shown in Fig. 3c in which a wedge-shaped prism 310 has a source beam input face 312 perpendicular to the direction of the output beam 314 and an output face 316 at an angle to the input face 312. The wedge is rotated such that the output face presents the same angle of incidence to different source laser beams 318a, 318b, 318c, 318d in 10 turn as these are sequentially pulsed. Accordingly, the difference in angle of incidence of each of these beams is once again compensated by the rotating wedge to provide a common output path 314. As the laser pulses are equally separated in time and the wedge is rotating at a constant angular velocity the laser sources are equally separated in angle. Alternatively the output face may 15 be perpendicular to the direction of the output beam and the input face may be at an angle to the output face or both faces may be at an angle to the direction of the output beam.

20 The resulting beam is temporally and angularly multiplexed with an average power of $N \times$ (source average power) and a repetition frequency of $N \times$ (source repetition frequency) where N is the number of sources. A beam multiplexed in this way may be further combined (e.g. by use of spatial multiplexing as discussed above).

25 As a result of this arrangement polarisation independent multiplexing for multiple lasers can be achieved.

Furthermore as a result of this arrangement the average power scaling up can be controlled independently from peak intensity on target i.e. the average



power on target can be increased without increasing the peak intensity on the target.

5 The combination of spatial and temporal multiplexing allows the laser average power on the EUV target to be scaled up, as a result increasing the EUV average power output. This is achieved as follows from equation 1: laser power intensity on target is increased until optimum conversion efficiency of EUV radiation is achieved, then scaling up the average power is achieved by temporal multiplexing.

10

It will be appreciated that individual elements and steps from the various embodiments can be combined or juxtaposed as appropriate. Any appropriate laser can be used, together with any appropriate optical elements to achieve the desired effects. Also the approach can be used to obtain high powers for any appropriate application and continuous lasers can be used where appropriate.

15 The approaches, when combined, can be combined in any order.



Claims

1. A laser multiplexing element comprising a compound lens comprising at least two focusing elements arranged to focus at least two respective laser beams onto a common target.
2. An element as claimed in claim 1 in which the compound lens comprises an array of lenses.
3. A laser including an element as claimed in claim 1 or claim 2.
4. A method of multiplexing laser beams comprising temporally interleaving at least two pulsed laser beams.
5. A method as claimed in claim 4 in which the least two laser beams are spatially separated and in which a variable deviation element focuses the laser beams onto a common target area.
6. A method as claimed in claim 4 or claim 5 in which the variable deviation element is moveable so as to focus the temporally interleaved beams onto the common target area.
7. A method of multiplexing laser beams comprising the steps in any order, of spatially multiplexing laser beams onto a common target area and temporally interleaving the spatially multiplexed beams.
8. A laser multiplexing apparatus comprising at least two pulsed laser sources for generating pulsed laser beams and a temporal multiplexing element arranged to temporally interleave at least two pulsed laser beams.



9. An apparatus as claimed in claim 8 in which the temporal multiplexing element comprises a variable deviation element.
- 5 10. An apparatus as claimed in claim 9 in which the variable deviation element comprises a moveable reflector or wedge.
11. An apparatus as claimed in claim 9 in which the variable deviation element comprises a moveable refractor.
- 10 12. An apparatus as claimed in any of claims 8 to 11 further comprising a laser multiplexing element as claimed in any of claims 1 to 3.
- 15 13. An EUV generation apparatus comprising a laser as claimed in any of claims 1 to 3 and/or an apparatus as claimed in any of claims 8 to 12.
14. A laser plasma production apparatus comprising a laser as claimed in any of claims 1 to 3 or a laser apparatus as claimed in any of claims 8 to 12.



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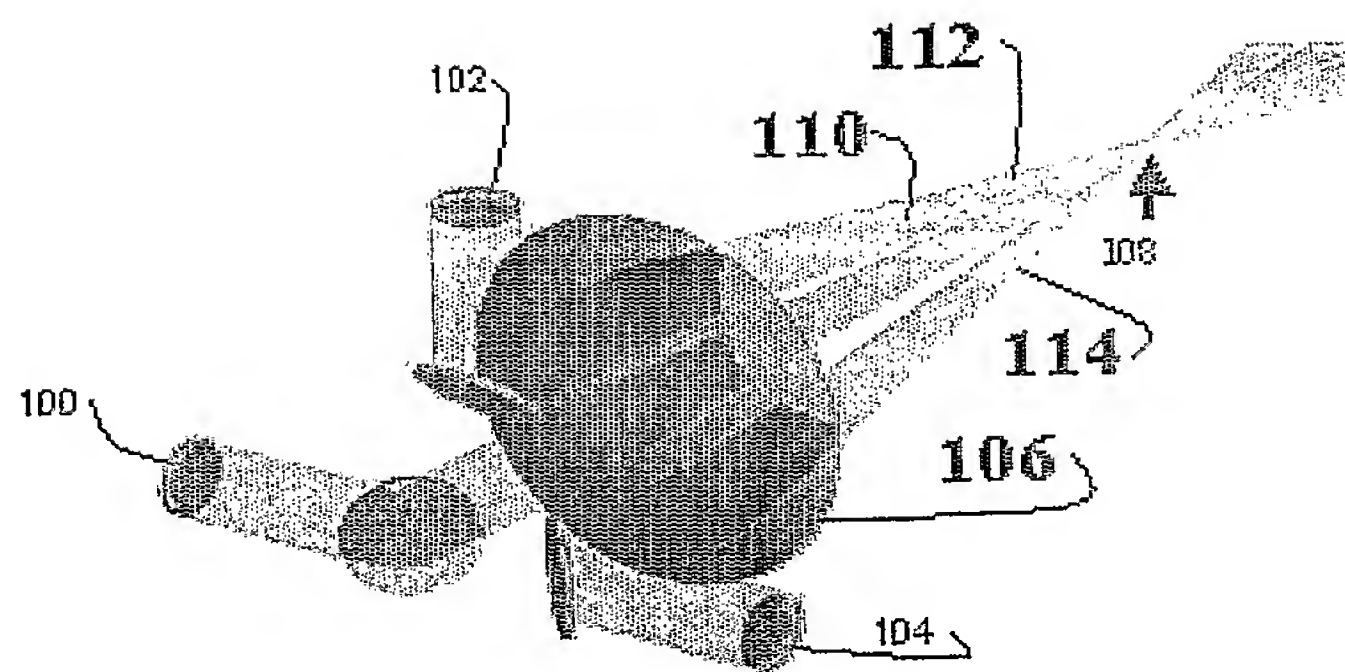


FIG. 1



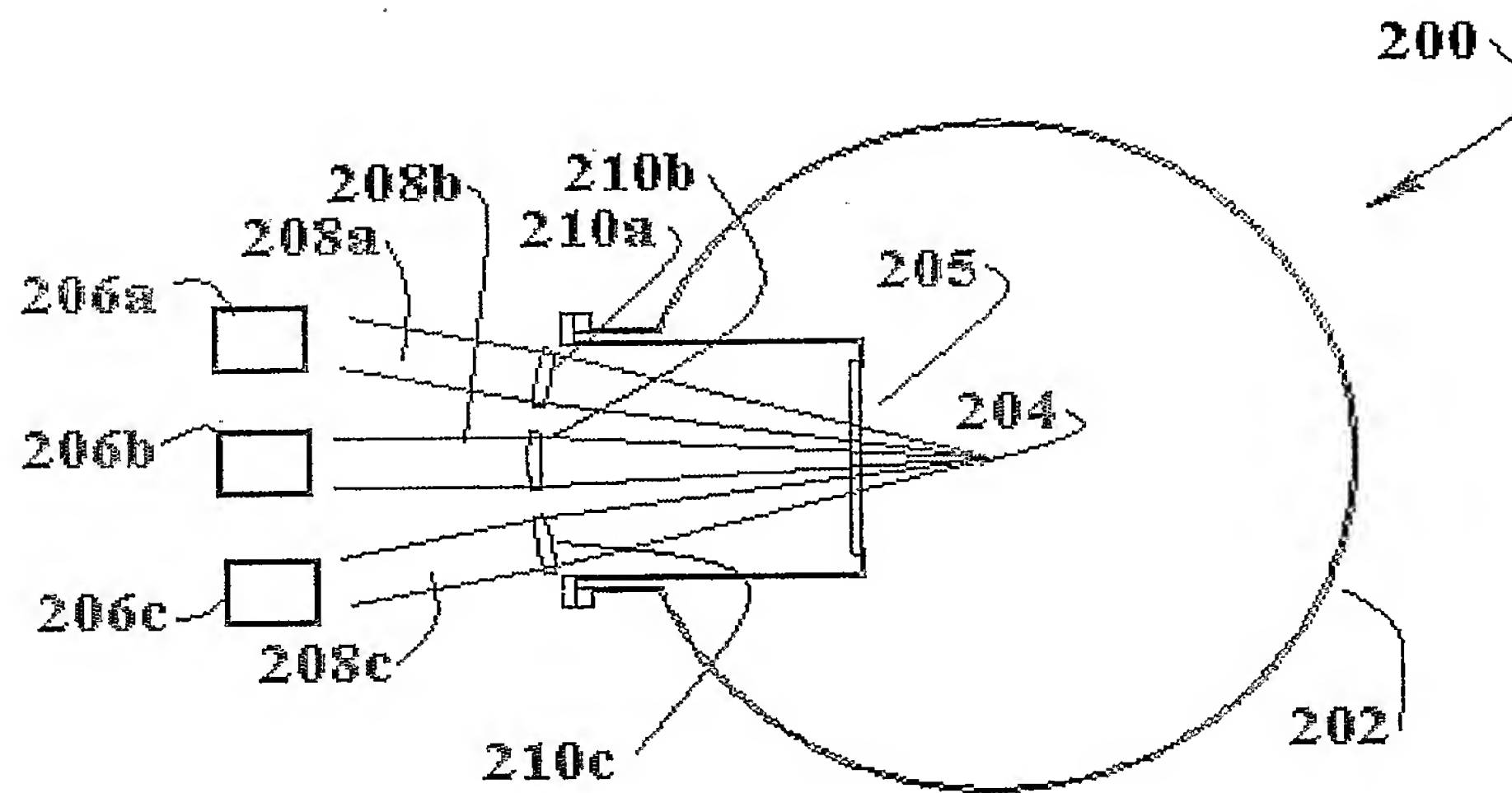


FIG. 2



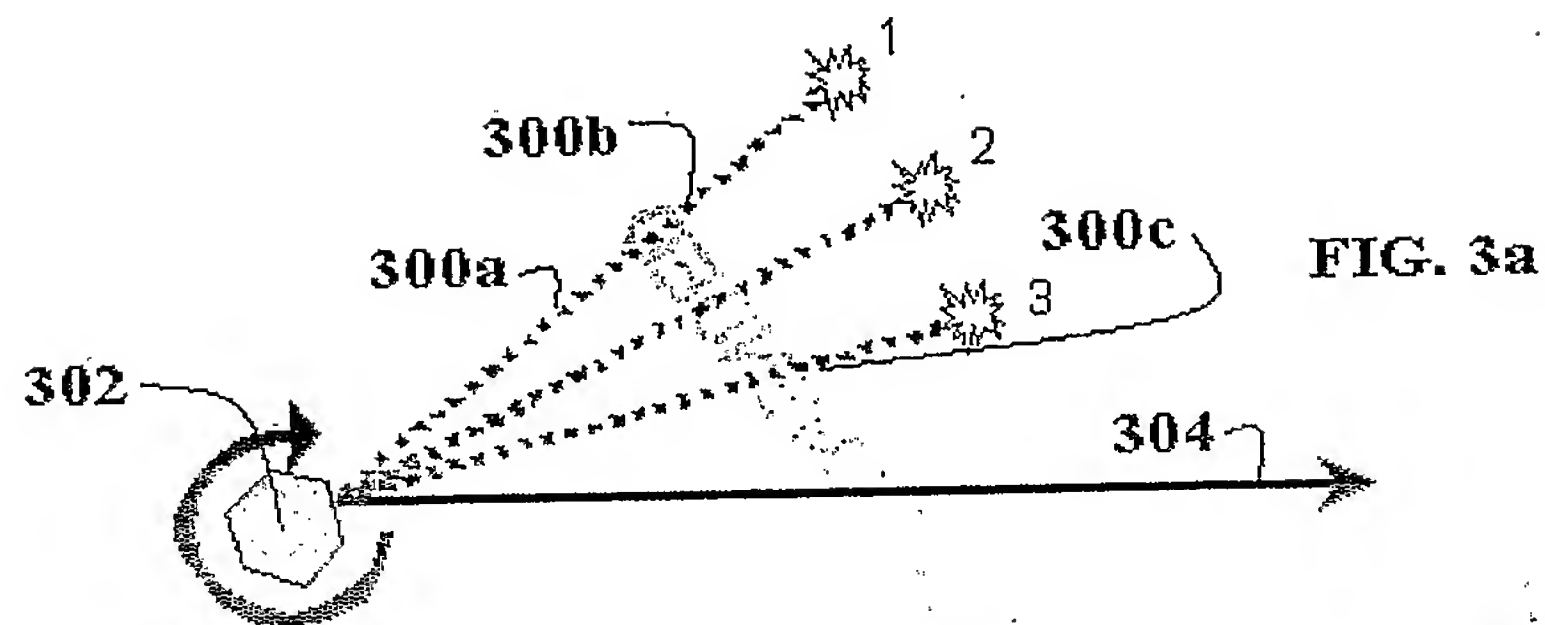


FIG. 3a

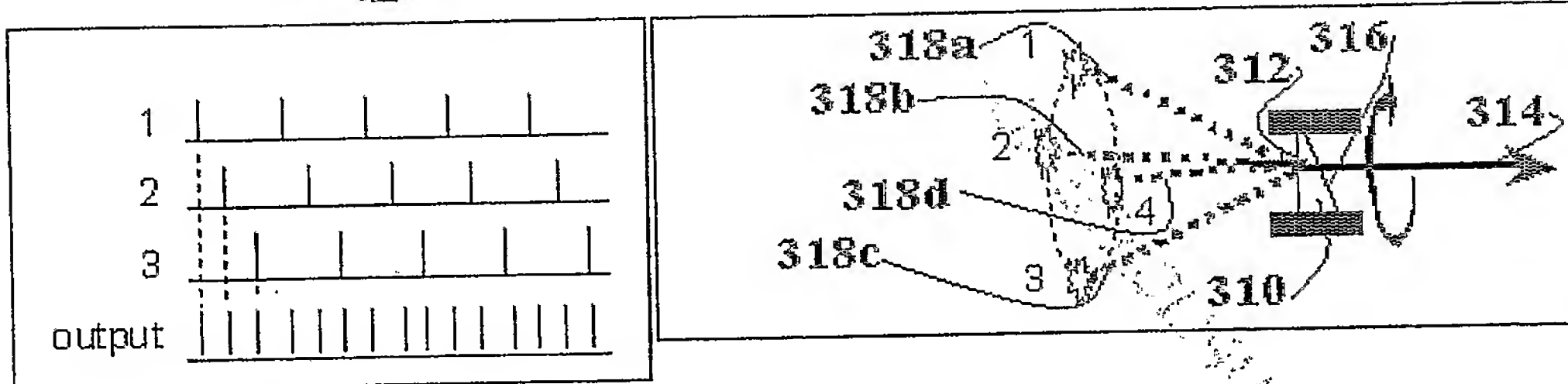


FIG. 3b

FIG. 3c

